

| | Application No. | Applicant(s) | | |
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| Notic of Allowability | | | | |
| | 10/602,137 Examin r | MA ET AL. Art Unit | | |
| · | | | | |
| | Pamela E Perkins | 2822 | | |
| The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31 | S (OR REMAINS) CLOSED in i) or other appropriate commu RIGHTS. This application is s | this application. If not including this application. If not include the transfer in the mailed in due to the transfer in the t | ded e course. THIS | |
| 1. \boxtimes This communication is responsive to <u>the amendment filed</u> | l on 21 May 2004. | | | |
| 2. X The allowed claim(s) is/are 19-22,24,27 and 36-41. | | | | |
| 3. \boxtimes The drawings filed on <u>23 June 2003</u> are accepted by the l | Examiner. | | | |
| 4. ☐ Acknowledgment is made of a claim for foreign priority of a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have a longer of the priority documents have a longer of the certified copies of the priority documents have a longer of the longer of the l | re been received. re been received in Applicatio | n No | ation from th | |
| Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. | | a reply complying with the re | equirements | |
| 5. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which giv | | | NOTICE OF | |
| 6. ☐ CORRECTED DRAWINGS (as "replacement sheets") mu (a) ☐ including changes required by the Notice of Draftsper 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in | rson's Patent Drawing Review r's Amendment / Comment or 1.84(c)) should be written on the | in the Office action of | ne back) of | |
| DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT | osit of BIOLOGICAL MATE FOR THE DEPOSIT OF BIO | ERIAL must be submitted. DLOGICAL MATERIAL. | Note the | |
| Attachm nt(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/Pap r No./Mail Date | 6. Interview Su Paper No./ (08), 7. Examiner's 8. Examiner's 9. Other | formal Patent Application (PT ummary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Al AMIR ZARABIAN JPERVISORY PATENT EXAM TECHNOLOGY CENTER 286 | lowance | |

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DETAILED ACTION

This office action is in response to the filing of the amendment on 21 May 2004. Claims 19-22, 24, 27 and 36-41 are pending; claims 1-18, 23, 25,26 and 28-35 have been canceled.

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

Claim 19 has been amended as follows:

19. A process of fabricating a microelectronic package, comprising:

providing a die affixed to a carrier substrate, the substrate having formed therein a through-hole extending from a first exterior surface to a second exterior surface of the substrate, the through-hole configured to allow the flow of an underfill encapsulation material into a gap between the die, the substrate, and the <u>a</u> heat spreader;

coupling a <u>the</u> heat spreader to the backside of the die using heat conductive adhesive, the heat spreader including a plurality of pillars surrounding the die to shift thermally induced stress away from the comers and edges of the die to the pillars of the heat spreader; and

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dispensing of an underfill encapsulation material through the through-hole such that the underfill encapsulation material flows into a gap between the die, the heat spreader, and the substrate.

Allowable Subject Matter

Claims 19-22, 24, 27 and 36-41 are allowed.

Reasons for Allowance

The following is an examiner's statement of reasons for allowance: prior art does not anticipate, teach, or suggest a process of fabricating a microelectronic package where a die is affixed to a carrier substrate, the substrate having formed therein a through-hole extending from a first exterior surface to a second exterior surface of the substrate, the through-hole configured to allow the flow of an underfill encapsulation material into a gap between the die, the substrate, and the heat spreader; coupling a heat spreader to the backside of the die using heat conductive adhesive, the heat spreader including a plurality of pillars surrounding the die to shift thermally induced stress away from the corners and edges of the die to the pillars of the heat spreader; and dispensing of an underfill encapsulation material through the through-hole such that the underfill encapsulation material flows into a gap between the die, the heat spreader, and the substrate.

For example, Mertol et al. (6,114,761) disclose a process of fabricating a microelectronic package where a heat spreader is coupled, using a heat conductive

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adhesive, to the backside of a die, wherein the heat spreader including a plurality of pillars that shift thermally induced stress away form the corners and edges of the die. Mertol et al. further disclose attaching mechanical reinforcements between a substrate and the heat spreader. Mertol et al. also disclose the die affixed of the substrate with a plurality of solder balls dispose on an active surface of the die aligned with a plurality of bond pad disposed on an active surface of the substrate. However, Mertol et al. do not disclose, anticipate, teach, or suggest the substrate having formed therein a throughhole extending from a first exterior surface to a second exterior surface of the substrate, the through-hole configured to allow the flow of an underfill encapsulation material into a gap between the die, the substrate, and the heat spreader; and dispensing of an underfill encapsulation material through the through-hole such that the underfill encapsulation material flows into a gap between the die, the heat spreader, and the substrate.

Weber (6,157,086) discloses a process of fabricating a microelectronic package where a through-hole extending from one exterior surface of a substrate to another exterior surface of the substrate, wherein the through-hole is configured to allow for passage of underfill material to flow around solder bumps of a chip which are used connect the chip to the substrate. Weber further discloses using the through-hole as a vent hole such that air can escape during an underfill of a flip-chip bonding to the substrate. However, Weber does not disclose, anticipate, teach or suggest the through-hole configured to allow the flow of an underfill encapsulation material into a gap between the die, the substrate, and the heat spreader.

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The prior art made of record in this action does not anticipate, teach, or suggest a process of fabricating a microelectronic package where a die is affixed to a carrier substrate, the substrate having formed therein a through-hole extending from a first exterior surface to a second exterior surface of the substrate, the through-hole configured to allow the flow of an underfill encapsulation material into a gap between the die, the substrate, and the heat spreader; coupling a heat spreader to the backside of the die using heat conductive adhesive, the heat spreader including a plurality of pillars surrounding the die to shift thermally induced stress away from the corners and edges of the die to the pillars of the heat spreader; and dispensing of an underfill encapsulation material through the through-hole such that the underfill encapsulation material flows into a gap between the die, the heat spreader, and the substrate.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Pamela E Perkins whose telephone number is (571) 272-1840. The examiner can normally be reached on Monday thru Friday, 9:00am to 5:30pm.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on (571) 272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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PERVISORY PATENT EXAMINER
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